



JFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Visco et al

Attorney Docket No.: PLUSP027

Application No.: 10/686,189

Examiner: Cantelmo, Gregg

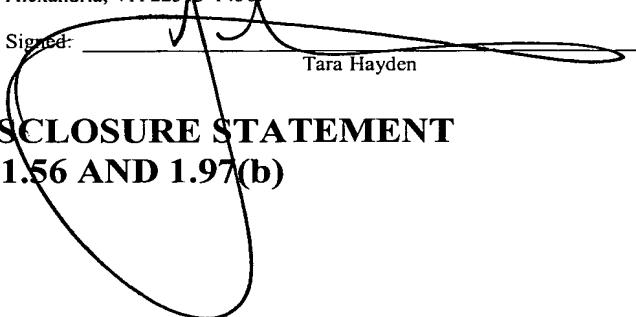
Filed: October 14, 2003

Group: 3774

**Title: IONICALLY CONDUCTIVE  
COMPOSITES FOR PROTECTION OF ACTIVE  
METAL ANODES**

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on July 14, 2006 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

Signed: 

Tara Hayden

**INFORMATION DISCLOSURE STATEMENT  
37 CFR §§1.56 AND 1.97(b)**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

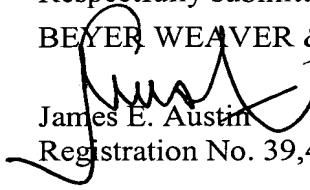
The reference listed in the attached PTO Form 1449, copy of which is attached, may be material to examination of the above-identified patent application. Applicants submit this reference in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make this reference of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. PLUSP027).

Respectfully submitted,

BEYER, WEAVER & THOMAS, LLP

  
James E. Austin  
Registration No. 39,489

P.O. Box 70250  
Oakland, CA 94612-0250



<b>Form 1449 (Modified)</b>		Atty Docket No.	Application No.:
<b>Information Disclosure Statement By Applicant</b>		PLUSP027	10/686,189
		Applicant:	
		Visco et al.	
		Filing Date	Group
		10/14/03	1745
(Use Several Sheets if Necessary)			

## U.S. Patent Documents

### **Foreign Patent or Published Foreign Patent Application**

## Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	West, et al., "Chemical stability enhancement of lithium conducting solid electrolyte plates using sputtered LiPON thin films," Journal of Power Sources, Volume 126, Issues 1-2, Pages 1-272 (16 February 2004)
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.